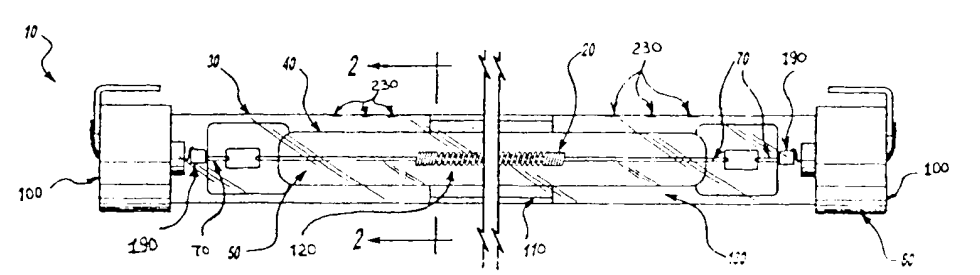


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(54) Title: SELECTIVE ELECTROMAGNETIC WAVELENGTH CONVERSION DEVICE		
		
(57) Abstract <p>A method and apparatus for increasing the output of an infrared emitter (10). High temperature concerns affecting the radiant energy transfer efficiency of the infrared emitter (10) are addressed by varying the emitter tube design and varying the locations of both the reflective (110) and high (220) emissivity materials located on the emitter constituent parts. A cooling fluid may be passed through the emitter (10) from both ends to allow higher power density or to cool the emitter (10) during its operation. Selectable wavelength infrared emissions are achieved through the design of the infrared emitter (10).</p>		

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SELECTIVE ELECTROMAGNETIC WAVELENGTH CONVERSION DEVICE

TECHNICAL FIELD

The present invention relates to an infrared emitter and, and more particularly, a method and apparatus for increasing the output of an infrared emitter.

BACKGROUND OF THE INVENTION

Infrared emitters provide radiant heat in numerous applications. For instance, they are the preferred heat source for drying paints supplied to metal surfaces, including solvent based paints, water based paints, and powder paints. They also provide heat for environmental test chambers and many industrial processes.

A typical infrared emitter includes a slender tubular quartz enclosure containing an elongated coiled filament that extends through the enclosure and connects to lead-in conductors at opposite ends of the enclosure. Infrared radiation emanates from the filament in all directions in a spherical pattern, and thus the power of the radiant energy decreases in proportion to the square cube of the distance from the emitter. Only the energy which is absorbed by the object is transferred to the object as heat energy, and of the energy which strikes the object, a portion will be reflected, a portion will be absorbed, and depending upon the object, a portion may be transmitted through the object. Only the radiant energy which actually strikes the object and is absorbed provides heat within the object. The remaining radiant energy is redirected or continues travelling through space, thereby reducing the overall energy transfer efficiency from the infrared emitter to the object to be heated.

To improve the radiant energy transfer efficiency, the radiant energy leaving the emitter is generally focused in some manner towards the object to be heated. In one approach the infrared emitters are employed within an enclosed

tubular sheath having reflective walls. The energy not directly passing from the infrared emitter to the object and absorbed by the object, continues to be reflective off the surfaces of the chamber until it strikes the object, escaping from an opening in the chamber or dissipating through inefficiencies and the reflectors.

5 In another application, where the heating chamber must be kept free of particulate matter and cleanliness is essential, the heating chamber of the infrared emitter is constructed using flat walls. This reduces the amount of dust that can form on the external reflectors of the infrared emitter.

In yet another application, a gold reflective coating has been placed on the
10 outer surface of the infrared emitter forming an integral reflector. This feature included with the aforementioned flat wall construction, provides an advantage of improving the radiant energy transfer efficiency and at the same time improving the cleanliness and the heating chamber environment. However, the gold reflective coating places restrictions upon the infrared emitter design. A gold
15 metal reflector coating may simply vaporize off of the surface of the enclosure due to excessive emitter temperature caused by trapped energy within the emitter system.

In still yet another application, an external sheath of quartz or other high transmissive material has been placed about the infrared emitter enclosure, with a
20 reflective metal coating applied to the outer sheath. U.S. Patent No. 5,382,805 addressed an infrared energy emitter which included a longitudinally extending tubular enclosure infrared energy transmitting material enclosing a longitudinally extending filament. A longitudinally extending outer tubular sheath of infrared energy transmitting material covered the tubular enclosure and was provided with
25 a reflector. This allowed the infrared emitter to run at high power densities while maintaining a relatively cool outer surface temperature. However, higher power densities adversely affect the end seals and reflective coatings. The aforementioned patent tried to overcome this high temperature concern by

providing fluid conductive filters at each end of the sheath to filter cooling fluid paths through the emitter. However, the ability to cool the infrared emitter by passing a cooling fluid into the enclosure at one end does not efficiently reduce the high temperature concerns with the integrity of the emitter while attempting to
5 improve the radiant energy transfer efficiency.

It is therefore a principle object of the present invention to provide a method for increasing the output power of an infrared emitter without sacrificing the structural integrity of the emitter. The high temperature concerns associated with the higher power density of the emitted infrared energy are addressed by
10 more efficient heat venting techniques.

It is still another object of the present invention to provide a longitudinally extending hermetically sealed tubular enclosure of infrared energy transmitting material enclosing the filament having at least one inner tubular support device in a predetermined position including a plurality of apertures for fluid flow
15 therethrough.

It is yet another object of the present invention to provide a heat sink which is intimately associated with an electrical conductor extending from the filament out through the tubular enclosure which encapsulates the emitting filament. The heat sink is used to assist in heat dissipation from the infrared
20 emitter and the filament electrical supply conductor, typically a pin.

It is still yet another object of the present invention to provide a longitudinally extending outer tubular sheath of infrared energy transmitting material having an inner and an outer surface with a plurality of ports strategically located at predetermined locations along the outer surface of the sheath. The
25 sheath will have two ends, each end will have at least one passage for fluid flow therethrough. A reflector, comprising a reflective coating on a surface of the sheath, will extend partially circumferentially with the sheath forming a central

longitudinal section for the transmission and/or absorption of secondary electromagnetic wave emission.

A heat dissipator comprising a high or low emissivity coating and is disposed over the reflector forming an intimate contact thereto. This also aids in
5 adjusting the temperature of the infrared emitter by strategically and controlled radiant means.

It is still another object of the present invention to provide that the ports be placed in the window of the outer tubular enclosure to direct the exhausted fluid toward the work in process. Alternatively, the ports can be placed so that the fluid
10 will be channeled away from the work in process. The ports also provide pressure relief to accommodate fluid flow into one or both ends of the emitter system.

It is still another object of the present invention to provide high watt densities from small outer tubular diameters while simultaneously cooling the
15 integral reflector material, the outer tubular enclosure, the reflector, and the window. The higher power output capabilities will reduce the overall quantity of emitters required for many systems without reducing the overall system output power while providing increased efficiency.

It is yet another object of the present invention to create different radiation
20 emission patterns by varying the cross-sectional tubular enclosure shape. These shapes may also be combined with other shapes to include a mixture of polygons.

It is yet another object of the present invention to provide an inner tubular support positioned in a predetermined location with respect to the sheath. In
25 addition to its support function, the inner tube support may include passages to permit the flow of the cooling fluid through the inner support. This may allow fluid flow passages configured to achieve a predetermined fluid flow pattern.

It is yet another object of the present invention to provide dual peak wavelengths of infrared emission efficiently from one infrared emitter. This may be accomplished with or without the use of a transducer housing.

It is still yet another object of the present invention to provide selectable
5 electromagnetic peak wavelength emissions.

SUMMARY OF THE INVENTION

The present invention relates to an apparatus and method for increasing the output power of an infrared emitter and addressing the concerns associated with the damaging and undesirable higher temperatures produced within the
10 electromagnetic emitter components. The apparatus and method of the present invention use unique reflection and heat dissipation techniques to accomplish the aforementioned.

In a preferred embodiment of the invention, the apparatus of the present invention includes a method for heating an object with infrared energy by passing
15 a current through an elongated filament, and may be disposed within an hermetically sealed cylindrical enclosure. Surrounding the enclosure is an outer elongated tubular sheath of infrared energy transmitting material having an inner and an outer surface with a plurality of ports strategically located at predetermined locations along the outer surface of the sheath. The sheath has two ends, and
20 each end has at least one passage for fluid flow therethrough. There is a reflective coating on an inner surface of the sheath extending partially, circumferentially with the sheath to form a central longitudinal section referred to as a window. A coating of predetermined emissivity is disposed on the outside of the sheath and is generally congruent to the reflective coating that resides on the
25 inner surface. The central longitudinal section of the sheath is spaced apart from the enclosure about the entire circumference of the enclosure sufficiently to protect the reflective coating from the infrared energy that is emitted by the filament. Infrared radiation from the filament is reflected off of the reflective

coating on the sheath, back toward the filament, thus passing infrared radiation towards an object from the filament through the window. A cooling fluid passes through the space between the sheath and the enclosure to cool the enclosure, sheath, the reflective coating and controlled emissivity coating.

BRIEF DESCRIPTION OF THE DRAWINGS

The various advantage of the present invention will become apparent to one skilled in the art by reading the following specification and subjoined claims and by referencing the following drawings in which:

Figure 1 is a side view of the infrared emitter arranged in accordance with the principles of the present invention and having fluid purging and exhaust ports.

Figure 2 is a cross-sectional view taken along the line A-A of Figure 1.

Figure 3 is an end view of the infrared emitter of Figure 1.

Figure 4 is an end view of the opposite end of the infrared emitter of Figure 1.

Figure 5 is a cross-sectional view of the infrared emitter taking along the line 5-5 of Figure 4.

Figure 6 is an end view of an inner tube support device for supporting the inner tube of the infrared emitter.

Figure 7 is an end view of a second inner tube support device for supporting the inner tube of the infrared emitter.

Figure 8 is an end view of the inner tube support device for supporting the inner tube and for creating a helical fluid flow within the outer tube.

Figure 9 is a side view of the infrared emitter having an inner tube support device and heat sink fins for cooling the electrical conductor of the infrared emitter and a wave converter housing.

Figure 10 is an end view of the heat dissipator shown in Figure 9.

Figure 11 is a cross-sectional view of an infrared emitter radiant heat dissipator having gold on the outside of the outer tube and a controlled emissivity material on the outer surface of the gold deposition.

Figure 12 is a radiant heat dissipator for an infrared emitter having gold formed on the inside of the outer tube and a controlled emissivity material on the outside of the outer tube.

Figure 13 is an optional configuration showing patterns of controlled emissivity material formed over the gold to regulate a percentage of radiant energy dissipated by the material.

Figure 14 is an optional configuration showing a series of lines of controlled emissivity material formed over the window to provide absorption and re-radiation of a different peak infrared emission, possibly combined with the original peak emission, thereby providing a multiple peak emissions or a single longer converted peak IR emission.

Figure 15 is an optional configuration showing a series of dots of controlled emissivity material formed over the window to provide absorption and re-radiation of a different peak infrared emission, possibly combined with the original peak emission, thereby providing a multiple peak emissions or a single longer converted peak IR emission.

Figure 16 is a perspective view of an infrared emitter having a selective electromagnetic peak wavelength conversion device.

Figure 17 is a cross-sectional view of the infrared emitter of Figure 16 showing the wavelength conversion device arranged so that no wavelength conversion occurs.

Figure 18 is a cross-sectional view of the infrared emitter of Figure 16 showing the wavelength conversion device arranged so that a first wavelength conversion occurs.

Figure 19 is a cross-sectional view of the infrared emitter of Figure 16 showing the wavelength conversion device arranged so that a second wavelength conversion occurs.

Figure 20 depicts a single tube infrared emitter having an integral
5 reflector.

Figure 21A depicts an end view of a filament support.

Figure 21B depicts a side view of a filament and filament support device.

Figure 22 is a three tube infrared emitter including an exhaust tube for controlled venting of purge fluid.

10 Figure 23 is a cross-sectional view of the three tube infrared emitter of Figure 22.

Figure 24 is a cross-sectional end view of the three tube design showing the outer exhaust tube.

Figure 25 depicts the split thread fastener detail for attaching the exhaust
15 tube to the outer tube of the infrared emitter.

Figure 26 depicts an exploded side view of the split thread fastener device for attaching the exhaust tube to the outlet tube of the IR emitter.

Figure 27 depicts a front view of the assembled exhaust tube fastener device.

20 Figure 28 depicts an exploded cross-sectional view of the exhaust tube fastener device

DETAILED DESCRIPTION OF THE INVENTION

Figure 1 illustrates an infrared emitter 10 according to the invention which emits electromagnetic radiation in the infrared portion of the spectrum. The
25 infrared emitter 10 includes a coiled tungsten wire filament 20 enclosed within a hermetically sealed inner tube enclosure 40 containing a halogen gas 50. A longitudinally extending outer tubular sheath of infrared energy transmitting material 30 has a plurality of ports 230 strategically located at predetermined

locations along the outer surface of the sheath. The sheath 30 has two end caps 60 with each end cap 60 having at least one passage 100 for fluid flow therethrough. A reflector 110 comprising a reflective coating on a surface of the sheath 30 extends partially, circumferentially with the sheath forming a central longitudinal section henceforth referred to as the window 120. A heat sink 190 is intimately associated with an electrical conductor 70 which extends from the filament 20 out through the enclosure 40. The heat sink 190 assists in reducing the temperature of the electrical conductor 70 during operation of the infrared emitter 10.

Referring to Figure 2, an interior space 130 is located between the outer tube 30 and the inner tube 40. This interior space 130 helps to protect the reflective coating 110 from the infrared energy being emitted by the filament 20. The interior space 130 is also a passage for the cooling fluid to flow which assists in cooling the reflector material 110, the outer tube 30, and the window 120.

The end caps 60 of the outer sheath 30 are depicted in Figure 3. Also depicted in Figure 3 is a passage for fluid flow 100 through the end cap 60. The other end cap 60 with its associated passage for fluid flow 100 is depicted in Figure 4.

The fluid flow passage in the interior space 130 is better depicted in Figure 5.

Figures 6 through 8 illustrate the various inner tube support devices that maintain the inner tube 40 in a predetermined position. These predetermined positions may include a position concentric with the outer tube 30, in or at a focal point or focal area, or in any other desired position. Materials for the support devices include high temperature material such as ceramic, glass or quartz, or any other material that withstands the temperature and radiation generated by the infrared emitter 10 without breakdown. The support device may also be plated with materials that are intended to strategically reflect the radiation.

The inner tube support devices 150, 160, and 190 include passages 140, 170 and 200 to permit passage of a cooling fluid through the inner support. The inner support permits the passage of fluid with a minimum of resistance or will impose a strategic resistance to direct the fluid flow. In some applications, a support desirably creates a back pressure of fluid flow to prevent a reverse flow from the opposite end with fluid flows into both ends simultaneously. In addition, because fluid can be introduced into both ends of the outer tube 30 due to certain pressure differentials which can exist within the separate fluid flow supplies that may reside on each end of the infrared emitter 10, a strategic back pressure induced on each end assures the proper fluid flow direction on both ends within reasonable differential pressure tolerances.

The various passages 140, 170 and 200 in the inner tube support devices 150, 160 and 190 through their designs, can achieve a predetermined fluid flow pattern. For example, Figure 6 depicts an inner tube support 150 with a passage 140 that provides uniform fluid flow into one or both ends of the infrared emitter 10. In Figure 7 the inner tube support device 160 with its associated passage 170 is designed to provide nonuniform fluid flow to create a loop-like current flow internal to the outer tube 30.

Figure 8 depicts an inner tube support device 190 with a passage 200 for fluid flow in a rotational pattern or in this case, clockwise motion.

It is desirable to minimize the thermal expansion of the electrical conductor that passes through the inner tube enclosure 40 on one or both ends. Thermal expansion of the electrical conductor 70 limits the current that passes through the electrical conductor 30 limiting the power output of the inner electromagnetic emitter 20. The amount of current flow at least partially determines the generation of heat within the conductor 70 that causes the expansion. If the current exceeds a predetermined threshold, such as 15 amps, then the conductor 70 expands at a rate that differs from the expansion rate of a

material like quartz, that contains it. The coefficient of expansion of the conductor material is relatively high compared to the coefficient of expansion of the quartz. If the conductor 70 becomes too hot, excessive conductor expansion resultantly cracks the hermetic seal at the end of the inner tube 40, damaging the inner
5 emitter tube assembly allowing the introduction of oxygen into the inner tube 40. Oxygen damages the structural integrity of the inner filament 20, commonly constructed from tungsten, doped tungsten, or tungsten alloy. Figure 9 depicts a heat sink 190, for the electrical conductor 70 of the inner tube 40 which intimately contacts the conductor 70. Heat is transferred out of the conductor 70 and into
10 the heat sink material by way of conduction. The heat energy is then transferred into the cooling fluid that passes over the heat sink fins which are evidenced in Figure 10. The heat sink 190 may be constructed from a material that possesses thermal conductivity, such as copper, aluminum, cermets or metal alloy. The heat sink 190 may also be plated with a highly reflective material that will not absorb
15 the vast majority of wavelengths of electromagnetic energy generated by the emitter device 10. The heat sink device 190 may act as either a conductor or insulator of electrical current depending on particular design considerations.

Referring to Figures 11-13, the invention includes a thin film integral gold, gold alloy, or high efficient reflector 110, which is placed on the outside surface of
20 the outer tubular enclosure 30. Component temperatures that achieve the latent heat of vaporization of the integral reflector material 110 limit the power density, normally measured in watts per linear inch. As the watt density increases, the outer tube enclosure 30 and integral reflective film material 110 increase in temperature and eventually attain temperatures that will vaporize the gold
25 reflective film 110. Trapped heat within the outer sheath limits watt density for any particular quartz sheath diameter, which is typically 0.625 inches in the outer diameter. The emitter 10 by having fluid purging that exits through exhaust ports 230 enables the infusion of a cooling fluid into the interior space 130 assist in

cooling the entire assembly, including the conductor cooling fin and reflective film material 110.

It is desirable to additionally dissipate the heat from the thin film reflector 110 without supplying increased internal or external air flow. This is accomplished by the use of a radiant heat dissipator 220 which can be seen in Figure 11 through 13. In Figure 11, the controlled emissivity material 220 is disposed over the reflector 110, where the reflector 110 resides on the external surface of the outer tube 30. As the entire emitter 10 rises in temperature, heat rapidly dissipates from the system and, therefore, the gold reflective film 110 through the high emissivity material 220.

If one examines the difference in magnitude between convective and radiant energy losses from any particular surface, it will become apparent that great differences exist where the surface has high emissivity. In the case of the integral gold reflector 110, the outer surface of the integral reflector material 110 has a low emissivity of about 0.08 at room temperature and about 0.18 at approximately 900°F. It is well known in the art that emissivity increases with temperature. The emissivity factor expresses a percentage of possible emissions based on the theoretical black body emitter that is used as the reference standard for emissivity ratings. The low emissivity reflective film 110 cannot sufficiently dissipate heat by means of radiant losses. Therefore, changing the outer surface characteristics of the material 30 or 110 can modify the thermal losses from the thin film material 110. This is accomplished by placing another film of material of controlled emissivity 220 in this embodiment, high in intimate contact with the lower emissivity reflective film 110 or sheath 30. The heat energy then flows by conduction from the gold film reflector 110 or sheath 30 into the high emissivity material 220, and is more efficiently dissipated into space by the new highly emissive surface by radiant means that does not require additional air movement. Examples of high emissivity materials 220 include cermets, ceramics, oxides, and

organic materials. These materials may vary in thickness from a thin film to a thick coating. Figure 12 demonstrates that the radiant heat dissipator 220 may be placed on the outer surface of the outer tube 30 with the reflector of gold 110 on the inside of the outer tube 40. The high emissivity heat dissipation material 220 is preferably disposed adjacent and congruent to the inside reflector 110 and is preferably concentric to the reflector 110 when the outer tube 130 is cylindrical as is in this embodiment. The dissipation of radiant energy from the radiant heat dissipator 220 may be limited by the rate of thermal conductivity of the material of the outer tubular enclosure 30 that serves to transfer energy to the dissipation device 220

To attenuate the quantity of energy dissipated the high emissivity material 220 may be printed as a pattern on the reflector 110, as in Figure 13. This permits a reduced and controlled radiant loss when using a dissipation material of very high emissivity. Figures 14 and 15 provide the conversion of a single peak electromagnetic emission to a modified single peak emission of a longer wavelength or to dual infrared peak emissions simultaneously from a single infrared emitter 10. The dual emission includes the original wavelength emission from the inner emitter filament 20 and a longer wavelength from the secondary surface on the window 120 of the outer tube 30. This is accomplished by placing on the window exterior or interior surface a high emissivity material 220 that absorbs the shorter wave energy, increases in temperature, and radiates the longer peak electromagnetic wavelength into space. This provides a fast thermal response medium or long wave emitter of high efficiency. The longer wavelength from the converting surface will be radiated from both the outside and the inside surfaces of the window. To attenuate the emission, the high emissivity material 220 may be placed on the window 120 in a pattern (see Figures 14, 15). The exhaust ports/cooling fluid ports 230 are also evident at predetermined locations, this embodiment, in the window 120.

Varying the amount of high emissivity material 220 printed on the window 120 varies the percentage of power of the longer wavelength emission. The secondary wavelength can be altered by changing the distance between the primary source of the energy, in our case, the tungsten filament, and the high
5 emissivity material 220. This is best accomplished by changing the outer diameter of the outer enclosure 30. A larger diameter outer tube 30 would decrease the temperature of the high emissivity material 220 that resides in the window 120, thereby altering its wavelength toward the longer peak emission period. This occurs because the energy would now be spread over a larger area
10 of material, but output power would remain relatively stable, except for increased convective thermal losses inherent to long wave emitters.

The exhaust/cooling fluid ports 230 in the outer tube of 30 of the emitter 10 enable fluid to pass into one end or both ends of the emitter 10 simultaneously. The fluid exits the exhaust ports 230, which are arranged
15 intermittently to the ends of the emitter 10. As previously indicated, it is preferable to maintain the ends of the inner tube 40 and/or the filament 20 at reasonably low temperatures during the operation of the emitter system. The exhaust ports 230 of this invention permit fluid to pass over one or both ends of the inner tube 40. This maintains the hermetic seal below the maximum recommended operating
20 temperature of about 550 degrees F. The passage of cooling fluid into both ends of the outer tube 30 will permit the flow of cooling fluid to protect both emitter end seals. The placement of the ports 230 in the window 120 of the outer tube 30 direct the heated exhaust fluid toward the work in process. Alternatively, the ports 230 can be placed so that the fluid will be channeled away from the work in
25 process. In addition, the exhaust ports 230 provide pressure relief to accommodate fluid flow into one or both ends of the emitter system 10 because the fluid can escape out of these strategically placed exhaust/cooling fluid ports 230.

In Figure 16, the infrared emitter 10 is encapsulated by a transducer housing 210. The entire housing 10 can be rotated so that the short-wave infrared emission can be utilized directly as in Figure 17. The housing 10 can be further rotated so that the short-wave emission is directed into a chamber 240 that
5 directs all emission toward a surface that has a particular radius. In such a position, the short-wave emission is absorbed and spread over a larger area and converted to a longer wavelength, such as a two-micron peak wavelength emission, and is emitted into the environment by the new high emissivity surface that resides on the inner and/or outer surface of the utilized chamber. The focal
10 point, or focal area, of the inside surface of the wave transducer is where the filament 20 resides itself which will promote efficiency by returning normally wasted energy back to the source of the radiant energy. The housing 210 can be further rotated to a new surface such as another chamber that has a second particular radius, for example a larger radius, as in Figure 19. A short-wave
15 emission is then absorbed by this larger absorbing and emitting surface and is converted to a longer wavelength, such as a three-micron peak wavelength emission. The converted wavelength may then be emitted by the new high emissivity surface that resides on the inner and/or outer surface of the utilized chamber. Figures 17-19 succinctly depict the transducer housing 210 with the
20 associate chambers of varying radii 240, in various modes of rotation around the infrared emitter 10.

The transducer housing 210 is constructed from a single high temperature material such as ceramic, quartz, metal, or cermet material. The housing 210 may also be constructed from a framework of ceramic, quartz, metal,
25 cermet, or other high temperature material, where the conversion surfaces that absorb and radiate the modified wavelength or of wavelengths of electromagnetic energy are inserted into the holding frame. The inner and/or outer conversion surfaces are coated with a material or materials that will absorb the primary

radiation with great efficiency. The exterior of the conversion surface will possess a high emissivity factor to enable the converted peak wavelength to be efficiently emitted into space. The materials on the inside may differ from the materials on the outside surface of any particular conversion/emitter surface. The materials
5 may differ on the inside and/or outside of said surfaces from one lobe 240 to the next, depended on the absorption characteristics of the particular primary wavelength, the emissivity of the outside emitting surface for any particular conversion surface temperature, and resulting peak emission from said surfaces.

The absorber/emitter surface of any particular lobe 240 may also be a
10 clear thermopane construction. A fluid that contains charged isotope particles may reside within the cavity of the thermopane construction, and be aligned with an electric current. This will permit either the passage of the primary wave of radiation with high levels of transmission or a varying percentage of absorption by the electronically rotated particles. The rotated particles, if positioned to absorb
15 the primary energy, increase in temperature, thereby increasing the emitting surface temperature of the conversion device, providing a peak wavelength conversion, or multiple peak emissions.

The cooling fluid from the emitter 10 passes through the cooling parts 230 in the outer sheath 30 into the particular chamber 240 that has been selected for
20 peak wavelength emission conversion to a longer wavelength. Strategically placed exhaust ports (not shown) in the housing 210 can permit the fluid flow out of the housing 210. These ports or holes may be placed along the perimeter of each of the conversion surfaces. This minimizes the conductive heat losses from the conversion emitter surface to the surrounding structural material, thereby
25 increasing the radiant efficiency. In addition, the exhaust air will contain significant heat energy that will serve to increase the radiant efficiency of the secondary radiant conversion surface. The inner surface of the walls of the

transducer housing 210 may also be plated, covered, or coated with a material that is highly reflective to the majority of the electromagnetic radiation emission.

The transducer housing 210 includes end fittings 310 that fit over each end of the transducer housing 210. The end fittings 310 accommodate the inner tube 40, and outer tube 30, and generally the infrared emitter 10. The fittings 310 act as an interface between the housing 210 and the outer tube 30, and permit an efficient seal to minimize and control cooling fluid losses. The fittings 310 also permit the rotation of the outer housing 210 around the outer tube 30 in order to select the proper position for the desired wavelength conversion. The fittings 310 may optionally include external clutches or gear teeth so that an external drive can automatically change the housing position relative to the stationary inner tube assembly. The inner surfaces of the fittings 310 may be plated, covered, or coated with a material that will efficiently reflect the primary and/or secondary radiant emissions. The fittings 310 and housing 210 may contain cooling ports 230, and may or may not be thermally insulated.

It is possible to have a single tube integral reflector emitter. Figure 20 depicts a single tube emitter which includes solely a tube 40 for the filament 20 of an infrared emitter 10. The single tube emitter is coated with a highly reflective material 110, such as gold, on the inside of the tube 40 and a high emissivity material optionally on the outside of the tube 220. The gold reflective film 110 and the high emissivity material 220 cover all but a predetermined portion of the infrared emitter 10. The radiant energy source 20 is held in position by the filament support 80.

The filament support 80 includes a high temperature material, such as tungsten, tantalum, or other high temperature alloy, which forms a wire. In Figure 21, the filament support 80 wraps in a direction opposite the direction in which the filament coil 20 wraps in order to prevent the filament coil 20 from slipping between the windings of the filament support 80. The filament support 80

includes a dielectric coating to electrically insulate the material from the filament 20 and the integral reflector material 110. The dielectric coating prevents current from flowing through the reflector material 110, resulting in an electrical short.

In Figures 22-28 an exhaust tube 250 encapsulates the inner 40 and outer 5 30 tube enclosures of the infrared emitter 10. The exhaust tube 250 directs cooling fluid flow between the inner 40 and the outer 30 tubes away from the work area. The exhaust tube 250 attaches to an exhaust fitting 260 which includes exhaust holes 280 for venting the cooling fluid escaping from the outer tube 30 completely away from the work area.

10 A split thread fastener 290 connects the exhaust tube 250 to the outer tube 30 of the infrared emitter 10. The split thread fastener 290 is split because the fastener cannot otherwise slide past the end caps 60 of the infrared emitter 10. The split thread fastener 290 includes at least two pieces each having teeth which mesh to form a unitary body when the split thread fastener 290 is installed.
15 The split thread fastener 290 also includes a refractory material 270 which is placed between the outer tube 30 and the inner surface of the fastener 290. Then the respective halves of the split thread fastener 290 engage the outer tube 30 and the fastener 290 is threaded onto the end of the exhaust fitting 260. The exhaust tube 250 exhausts the cooling fluid away from the work area. As
20 depicted in Figure 28, an O-ring 300 is interposed between the split thread fastener 290 and the exhaust fitting 260 in order to provide a seal.

Those skilled in the art can now appreciate from the foregoing description that the broad teachings of the present invention can be implemented in a variety of forms. Therefore, while this invention has been described in connection with
25 particular examples thereof, the true scope of the invention should not be so limited since other modifications will become apparent to the skilled practitioner upon a study of the drawings, specification and following claims.

CLAIMS

What is claimed is:

1. An infrared emitter comprising:
 - 5 a longitudinally extending energy emitting filament;
 - a longitudinally extending, tubular enclosure formed of infrared energy transmitting material, the enclosure enclosing the filament, the enclosure having at least one inner tubular support device in a predetermined position and a plurality of apertures for fluid flow therethrough;
 - 10 a longitudinally extending outer tubular sheath formed of infrared energy transmitting material, the outer tubular sheath having an inner and an outer surface and a plurality of ports at predetermined locations to allow fluid flow therethrough through the sheath;
 - a pair of end caps closing open ends of the outer sheath, each
 - 15 end cap having at least one passage for fluid flow therethrough;
 - a reflector formed on a surface of the sheath and extending partially circumferentially around the sheath to define a window through which infrared energy may pass; and
 - wherein the sheath is spaced apart from the enclosure to protect
 - 20 the reflector from the infrared energy being emitted by the filament.
2. An infrared emitter according to Claim 1 wherein the emitter comprises a tungsten filament and a gas filling the enclosure comprised of halogen.
3. An infrared emitter according to Claim 1 including a heat sink
- 25 intimately associated with an electrical conductor extending from the filament out through the enclosure.

4. An infrared emitter according to Claim 1 including a heat dissipater comprising a high emissivity coating disposed over the exterior reflector area forming an intimate contact with its substrate.
5. An infrared emitter according to Claim 1 wherein the filament has two ends, each end with an associated electrical conductor and corresponding heat sink.
6. An infrared emitter according to Claim 1 wherein the enclosure is a cylinder.
7. An infrared emitter according to Claim 1 wherein the enclosure is parabolic.
8. An infrared emitter according to Claim 1 wherein the enclosure is elliptical.
9. An infrared emitter according to Claim 1 wherein the sheath is a cylinder.
10. An infrared emitter according to Claim 1 wherein the sheath is parabolic.
11. An infrared emitter according to Claim 1 wherein the sheath is elliptical.
12. An infrared emitter according to Claim 1 wherein the inner tubular support is positioned concentric to the sheath.
13. An infrared emitter according to Claim 1 wherein the inner tubular support material is high temperature such as ceramic, glass, and quartz, and reflective to electromagnetic waves.
14. An infrared emitter according to Claim 1 wherein the inner tubular support is plated with an electromagnetic wave reflective material.
15. An infrared emitter according to Claim 1 wherein the inner tubular support device aperture is constructed to permit minimum resistance to fluid flow.

16. An infrared emitter according to Claim 1 wherein the inner tubular support device aperture is constructed to permit a resistance to fluid flow.

17. An infrared emitter according to Claim 1 wherein the inner
5 tubular support device aperture is constructed to create a back pressure of fluid flow.

18. An infrared emitter according to Claim 1 wherein the inner tubular support device aperture is constructed to create a predetermined fluid
10 flow pattern.

19. An infrared emitter according to Claim 1 wherein the inner tubular support device aperture is constructed to create a uniform fluid flow pattern.

20. An infrared emitter according to Claim 1 wherein the inner
15 tubular support device aperture is constructed to create a loop-like fluid flow pattern.

21. An infrared emitter according to Claim 1 wherein the inner tubular support device aperture is constructed to create rotational fluid flow pattern.

20 22. An infrared emitter according to Claim 1 wherein the inner tubular support device is constructed to accommodate the sheath and the enclosure.

23. An infrared emitter according to Claim 1 wherein the heat sink is constructed from a material with a rapid thermal conductivity, such as copper,
25 aluminum, cermet, and metal alloy.

24. An infrared emitter according to Claim 1 wherein the heat sink is designed to include a plurality of integral fins.

25. An infrared emitter according to Claim 1 wherein the heat sink is plated with an electromagnetic wave reflective material.

26. An infrared emitter according to Claim 1 wherein the outer surface of the sheath includes a disposed electromagnetic wave reflective film.

5 27. An infrared emitter according to Claim 1 wherein ultra-violet emissions are simultaneously emitted with the infrared energy.

28. An infrared emitter according to Claim 1 wherein the inner surface of the sheath includes a disposed integral electromagnetic wave reflective film.

10 29. An infrared emitter according to Claim 1 wherein a high emissivity material is disposed on a surface of the window for electromagnetic wavelength emission conversion.

30. An electromagnetic emitter according to Claim 1 wherein all emissions are comprised of greater than 50% within ultra-violet
15 electromagnetic wavelength band.

31. An infrared emitter according to Claim 26 wherein the reflective film includes gold.

32. An infrared emitter according to Claim 26 wherein the reflective film includes an outer surface disposed with an integral electromagnetic wave
20 high emissivity material.

33. An infrared emitter according to Claim 26 wherein the reflective film includes an outer surface with an integral electromagnetic wave high emissivity material disposed in a pattern.

34. An infrared emitter according to Claim 28 wherein the reflective
25 film includes gold.

35. An infrared emitter according to Claim 28 wherein the outer surface of the sheath includes a disposed electromagnetic wave reflective film.

36. An infrared emitter according to Claim 29 wherein the high emissivity material is disposed on a surface of the window in a pattern for multiple peak electromagnetic wavelength emissions.

37. An infrared emitter comprising:

5 a longitudinally extending energy emitting filament;

a longitudinally extending, tubular enclosure formed of infrared energy transmitting material, the enclosure enclosing the filament the enclosure having at least one inner tubular support device in a predetermined position and a plurality of apertures for fluid flow therethrough;

10 a longitudinally extending outer tubular sheath formed of infrared energy transmitting material, the outer tubular sheath having an inner and an outer surface and a plurality of ports at predetermined locations to allow fluid flow therethrough through the sheath;

a pair of end caps closing open ends of the outer sheath, each
15 end cap having at least one passage for fluid flow therethrough;

a reflector formed on a surface of the sheath and extending partially circumferentially around the sheath to define a window through which infrared energy may pass; and

wherein the sheath is spaced apart from the enclosure to protect
20 the reflector from the infrared energy being emitted by the filament,

a rotatable outer housing longitudinally extending along and partially circumferentially encapsulating the enclosure, the rotatable outer housing having a plurality of circumferential chambers wherein rotation of the housing positions a selected chamber to coincide with the window.

25 38. An infrared emitter according to Claim 37 wherein two end closures suitably constructed to interface between the housing and the enclosure, forming a seal and allowing circumferential rotations of the housing about the enclosure.

39. An infrared emitter according to Claim 37 wherein the housing is constructed from a single high temperature material such as ceramic, quartz, metal and cermet.

40. An infrared emitter according to Claim 37 wherein the housing is
5 constructed from a framework of high temperature material such as ceramic, quartz, metal, and cermet.

41. An infrared emitter according to Claim 37 wherein the inner wall is coated with a material that absorbs primary electromagnetic wave radiation and the outer wall is coated with a material that has a high emissivity factor to
10 emit electromagnetic wave radiation outward.

42. An infrared emitter according to Claim 37 wherein the ultra-violet emissions are simultaneously emitted with the infrared energy.

43. An infrared emitter according to Claim 37 wherein at least one chamber is clear thermopane.

15 44. An infrared emitter according to Claim 37 wherein the inner wall is coated with a material that is highly reflective to electromagnetic radiation emission such as aluminum, gold, stainless steel, ceramic, gold alloy, and metal alloy.

45. An infrared emitter according to Claim 37 wherein the end
20 closures include accommodations such that an external drive can automatically rotate the housing.

46. An infrared emitter according to Claim 37 wherein the end closures are coated with a electromagnetic wave reflective material.

47. An infrared emitter according to Claim 37 wherein the end
25 closures include cooling ports.

48. An infrared emitter according to Claim 37 wherein the end closures are thermally insulated.

49. An electromagnetic emitter according to Claim 37 wherein the total emissions are comprised of greater than 50% within the ultra-violet electromagnetic wavelength band.

50. An infrared emitter according to Claim 40 wherein the inner and
5 outer wall material varies throughout the housing.

51. An infrared emitter according to Claim 40 wherein the inner and outer wall material varies from chamber to chamber.

52. An infrared emitter comprising:

a longitudinally extending energy emitting filament;

10 a longitudinally extending, cylindrical enclosure formed of infrared energy transmitting material, the enclosure having an inner and outer surface enclosing the filament.

53. An infrared emitter according to Claim 52 wherein all but a predetermined portion of the inside surface of the enclosure is covered with a
15 reflector.

54. An infrared emitter according to Claim 52 wherein all but a predetermined portion of the outer surface of the enclosure is covered with a high emissivity material.

55. An infrared emitter according to Claim 52 wherein the filament
20 support comprises a high temperature material such as tungsten, tantalum, and other high temperature alloys.

56. An infrared emitter according to Claim 52 wherein the filament is wrapped in a coil direction.

57. An infrared emitter according to Claim 52 wherein the filament
25 support wraps in a direction opposite the direction of the filament coil.

58. An infrared emitter according to Claim 52 wherein the filament support includes a dielectric coating.

59. An infrared emitter according to Claim 52 wherein the filament support is coated with an insulating material.

60. An infrared emitter comprising:

a longitudinally extending energy emitting filament;

5 a longitudinally extending, tubular enclosure formed of infrared energy transmitting material, the enclosure enclosing the filament the enclosure having at least one inner tubular support device in a predetermined position and a plurality of apertures for fluid flow therethrough;

a longitudinally extending outer tubular sheath formed of infrared
10 energy transmitting material, the outer tubular sheath having an inner and an outer surface and a plurality of ports at predetermined locations to allow fluid flow therethrough through the sheath;

a pair of end caps closing open ends of the outer sheath, each end cap having at least one passage for fluid flow therethrough;

15 a reflector formed on a surface of the sheath and extending partially circumferentially around the sheath to define a window through which infrared energy may pass; and

wherein the sheath is spaced apart from the enclosure to protect the reflector from the infrared energy being emitted by the filament.

20 61. An infrared emitter according to Claim 60 wherein the exhaust tube includes two end fasteners and an O-ring interposed between an end fastener and an end cap.

62. An infrared emitter according to Claim 60 wherein the exhaust tube includes exhaust holes.

25 63. An infrared emitter according to Claim 60 wherein the end fasteners are split thread design.

64. An infrared emitter according to Claim 60 wherein the end fasteners are designed to slide past the end caps.

65. An infrared emitter according to Claim 60 wherein the end fasteners are each in two pieces.

66. An infrared emitter according to Claim 60 wherein the end fasteners include a refractory material attached to the inner surface area.

5 67. An infrared emitter according to Claim 60 wherein the ultra-violet emissions are simultaneously emitted with the infrared energy.

68. An electromagnetic emitter according to Claim 60 wherein the total emissions are comprised of greater than 50% within the ultra-violet electromagnetic wavelength band.

10 69. A method for heating an object with infrared energy comprising the steps of:

passing a current through an elongated filament to produce infrared energy, the filament being disposed within a hermetically sealed elongated tubular enclosure surrounding the enclosure with an outer elongated
15 tubular sheath of infrared energy transmitting material having an inner and an outer surface with a plurality of ports strategically located at predetermined locations along the outer surface of the sheath, the sheath having two ends, each end having at least one passage for fluid flow therethrough, a reflective coating on an inner surface of the sheath extending partially circumferentially
20 with the sheath and the central longitudinal section forming a window, a high emissivity coating disposed over the outer surface of the sheath and congruent to the reflective coating, and in intimate contact with its substrate, the central longitudinal section of the sheath being spaced apart from the enclosure about the entire circumference of the enclosure sufficiently to protect the reflective
25 coating from the infrared energy being emitted by the filament, reflecting infrared radiation from the filament off of the reflective coating on the sheath, back toward the filament, passing infrared radiation towards an object from the filament through the window, and passing a cooling fluid through the space

between the sheath and the enclosure to cool the end seals, the sheath, the reflective coating, and the high emissivity coating.

70. A method according to Claim 69 comprising the further step of incorporating a rotatable outer housing longitudinally extending along and
5 partially circumferentially encapsulating the enclosure, having a plurality of integral chambers so constructed that rotation of the housing can selectively position a chamber to coincide with the window, and two end closures suitably constructed to interface between the housing and enclosure, forming a seal and allowing circumferential rotation of the housing about the enclosure thus
10 accommodating selectable electromagnetic wavelength emission.

71. An infrared emitter according to Claim 69 wherein the ultra-violet emissions are simultaneously emitted with the infrared energy.

72. An electromagnetic emitter according to Claim 69 wherein the total emissions are comprised of greater than 50% within the ultra-violet
15 electromagnetic wavelength band.

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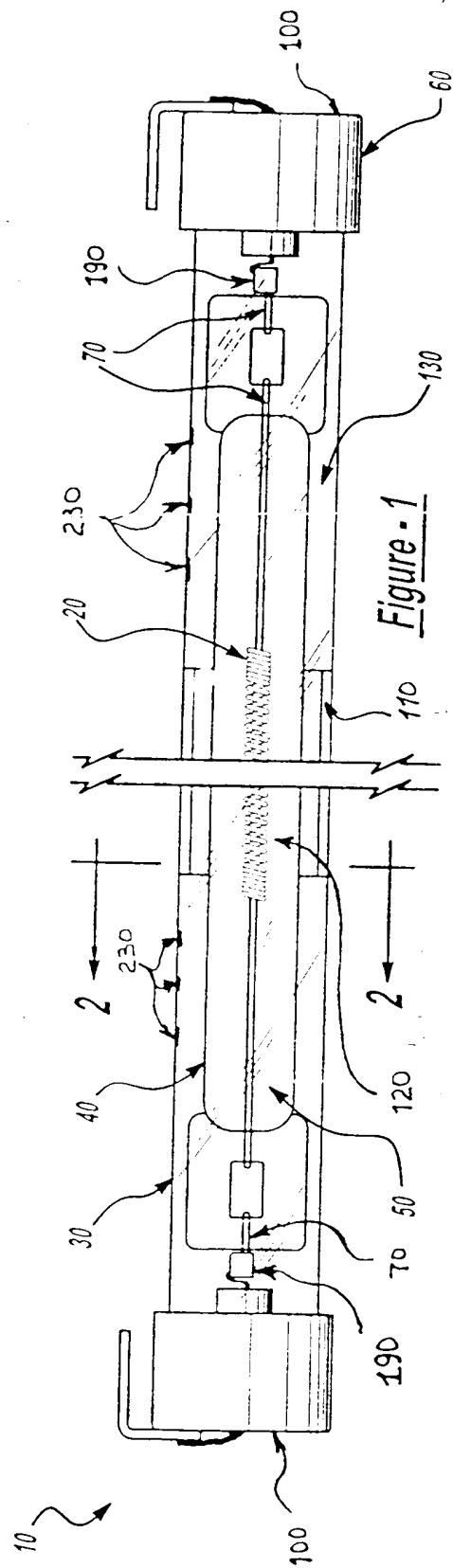


Figure - 1

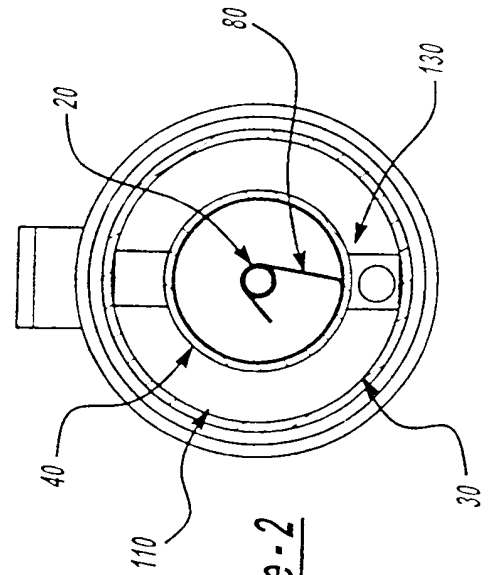


Figure - 2

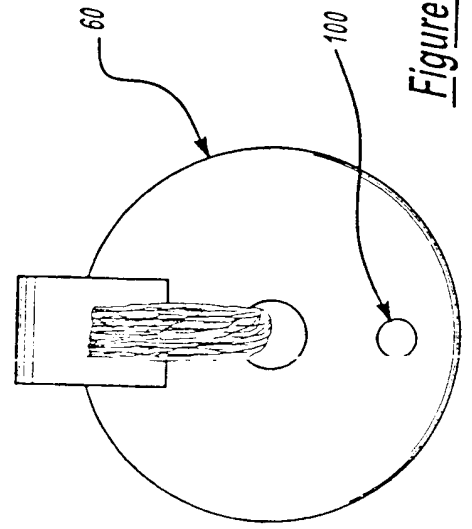


Figure - 3

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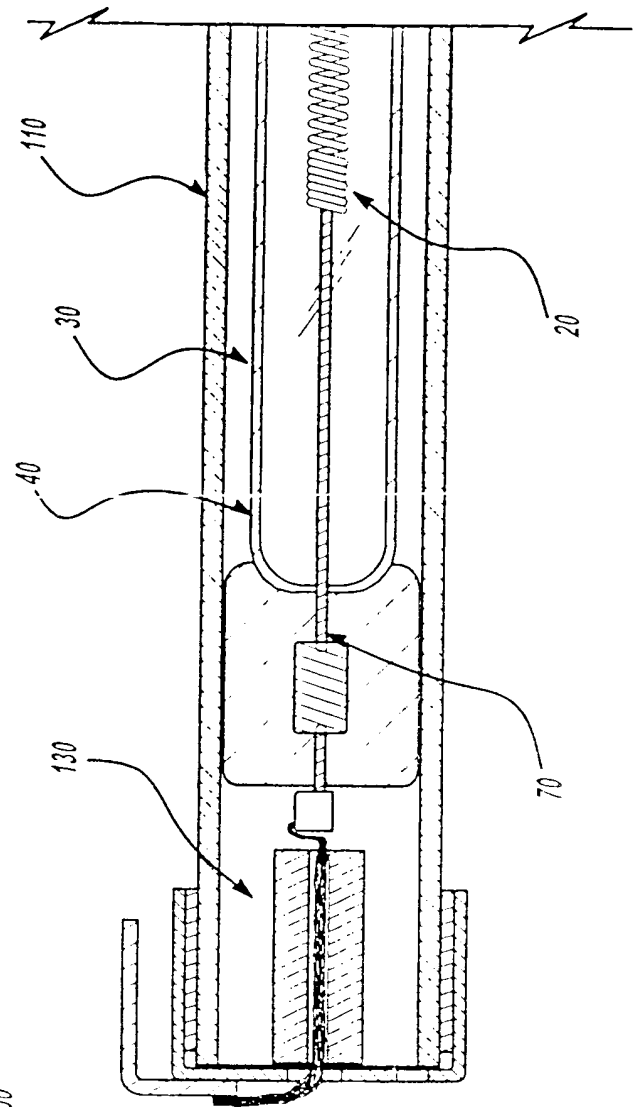
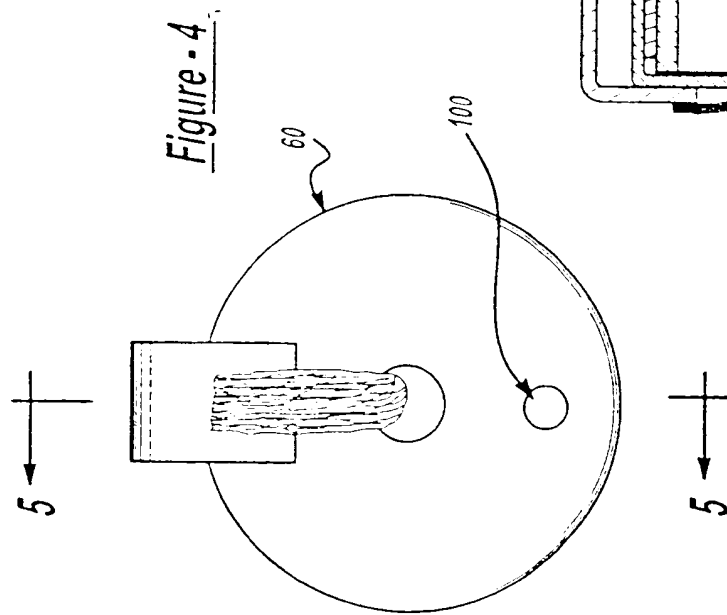


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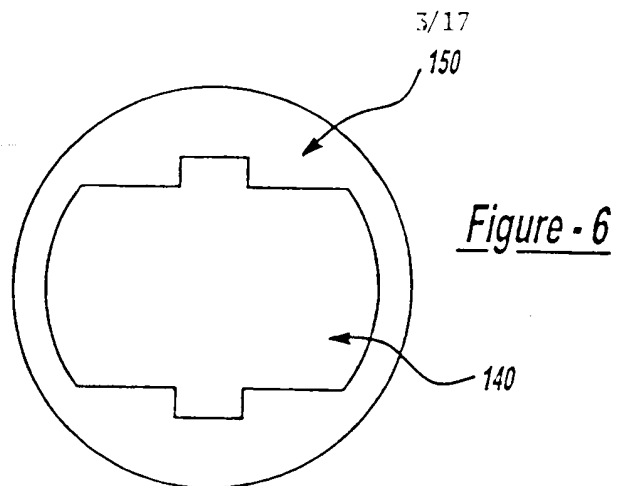


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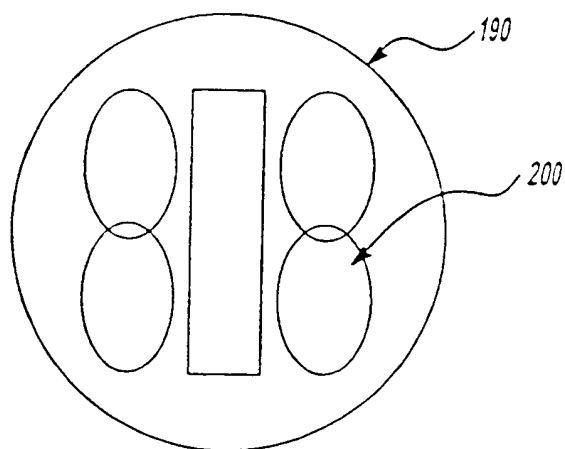
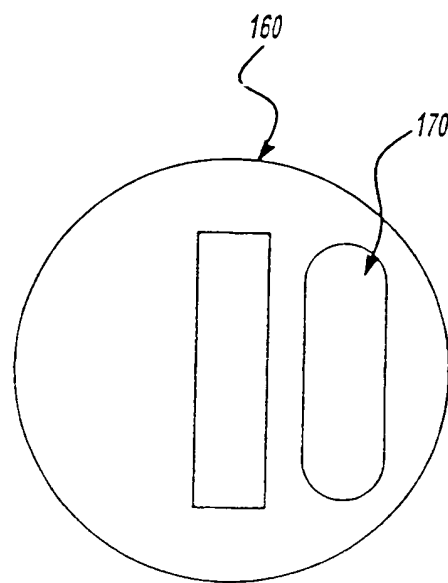


Figure - 8

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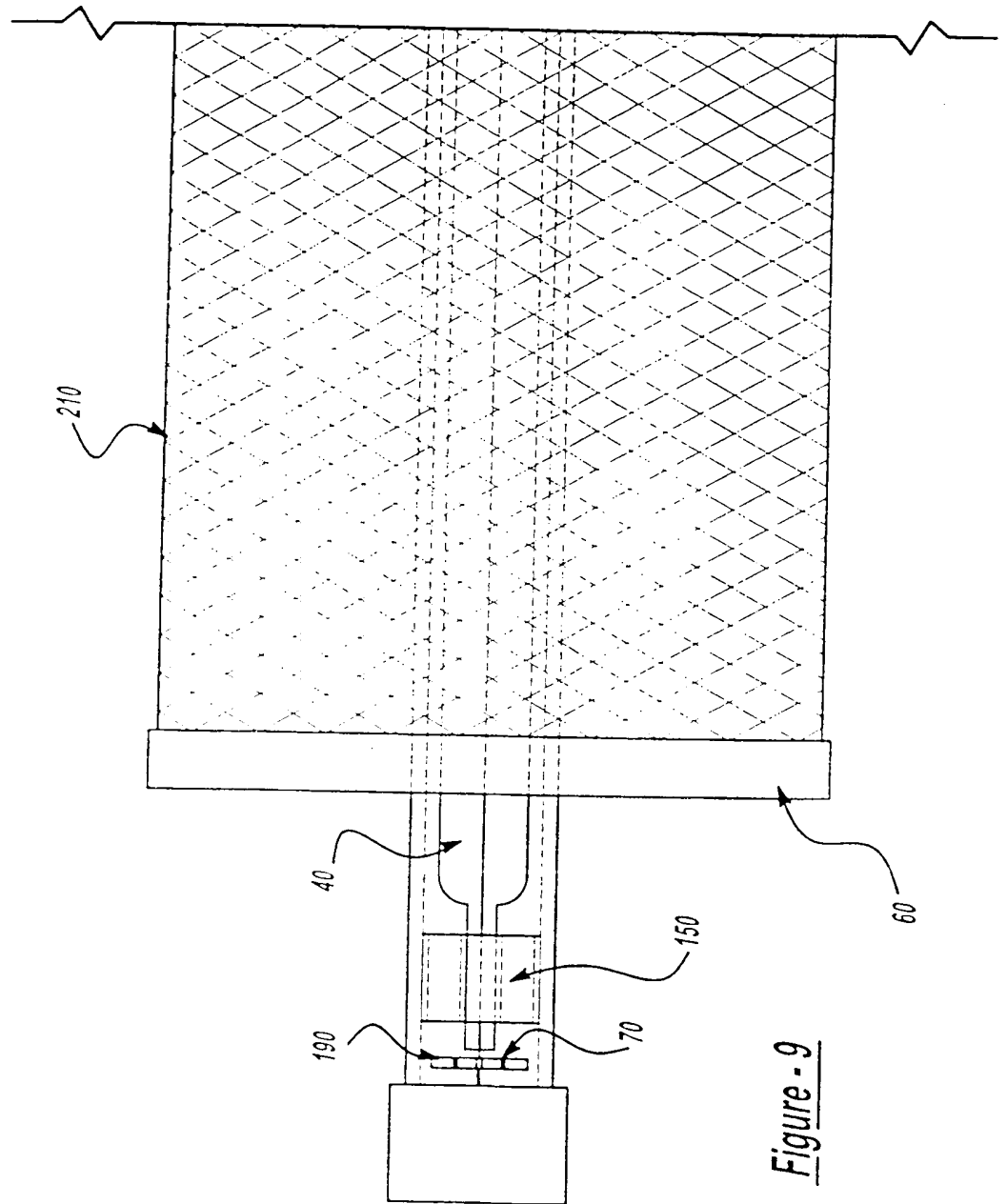
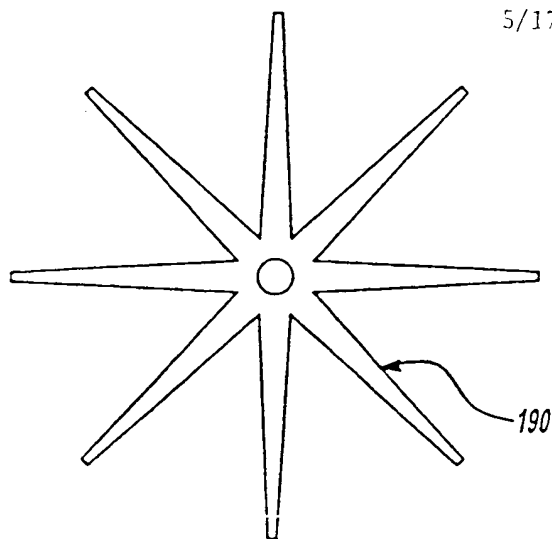
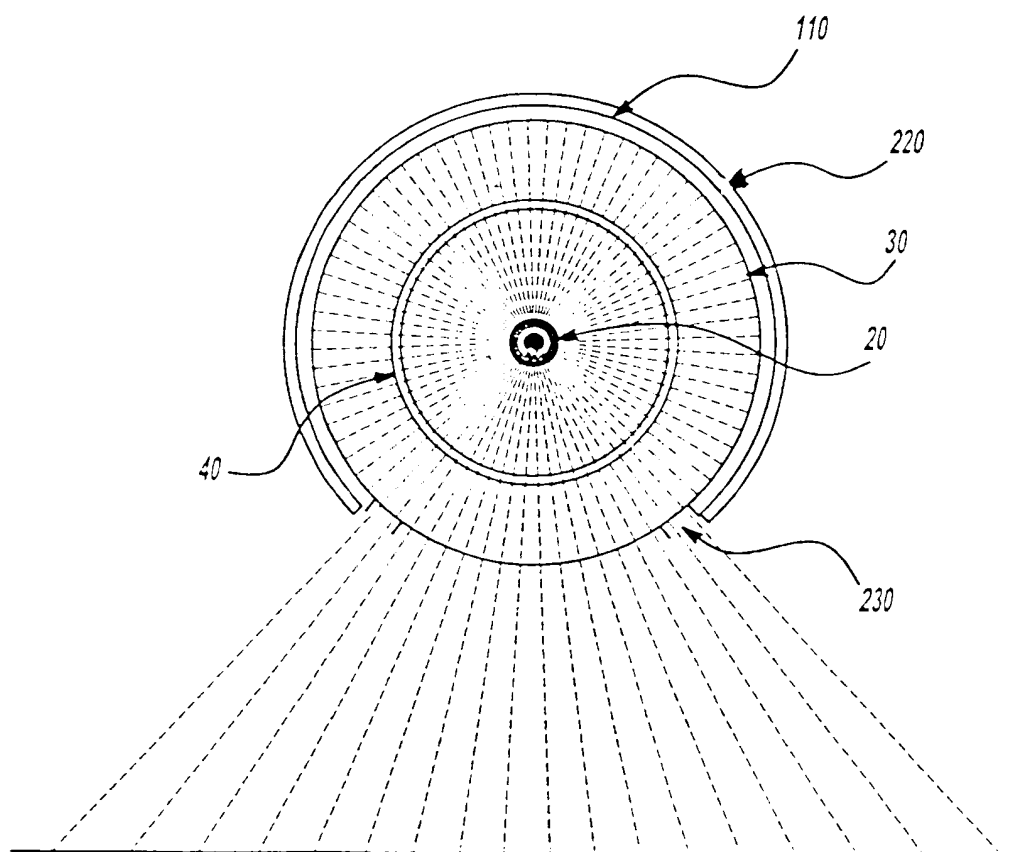


Figure - 9

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Figure - 10Figure - 11

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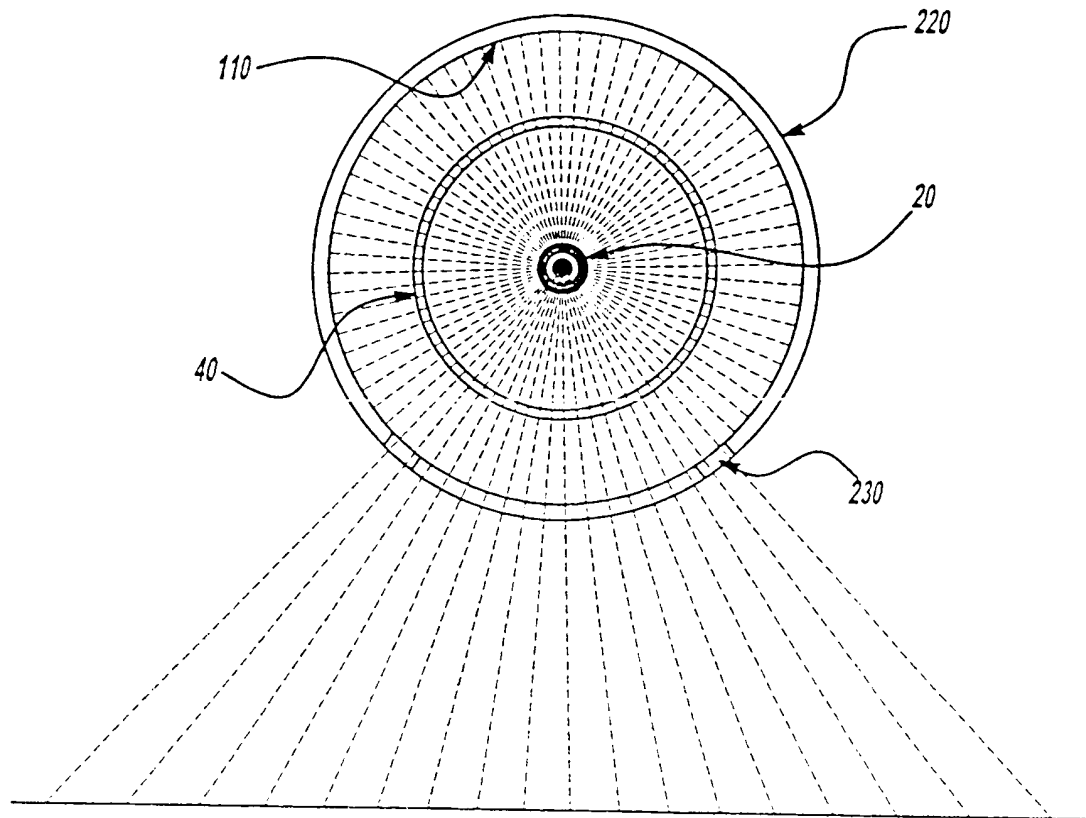
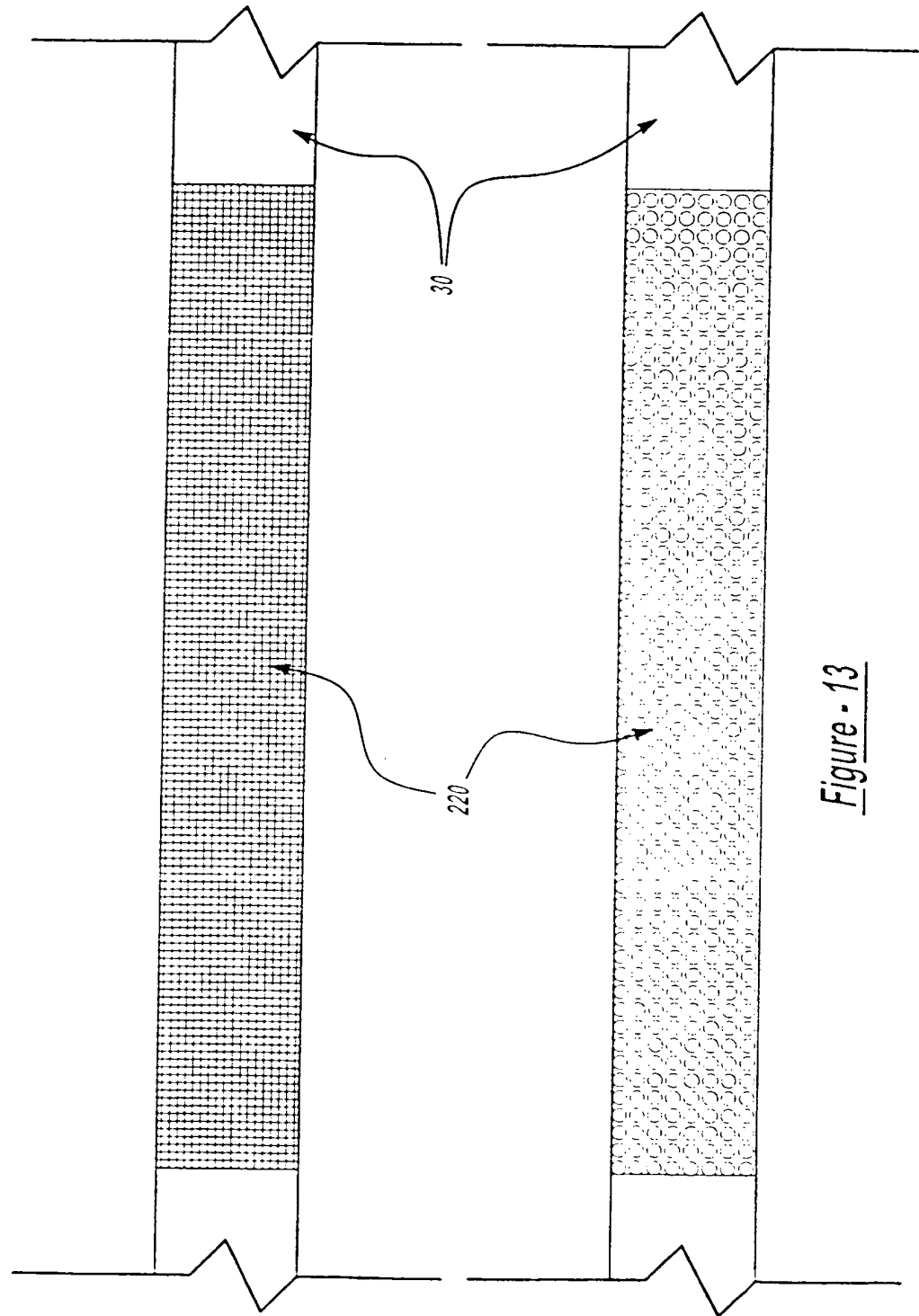


Figure - 12

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Figure - 13

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Figure - 14

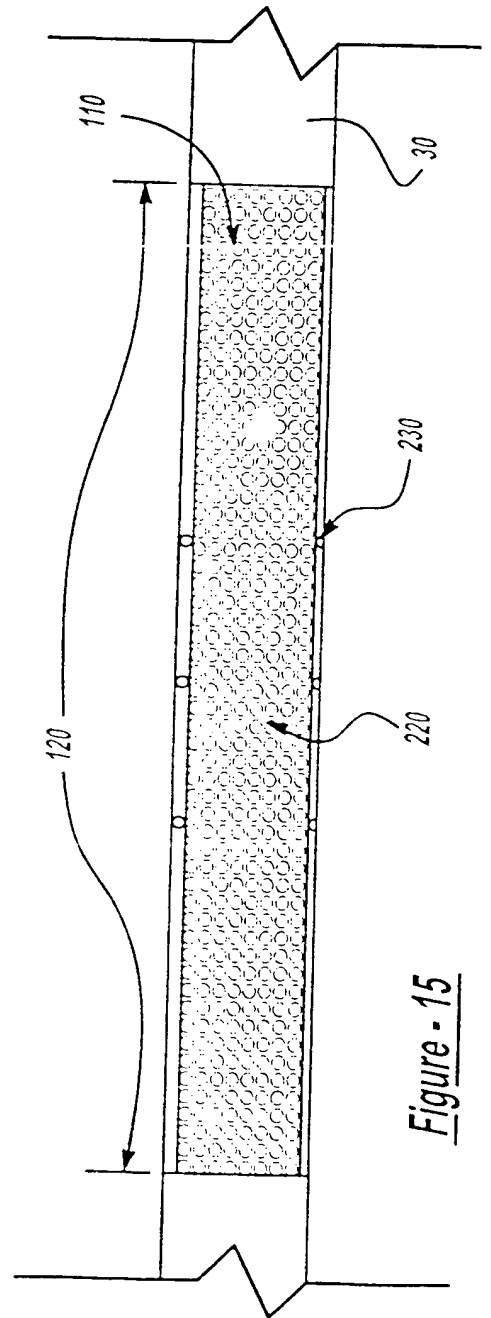
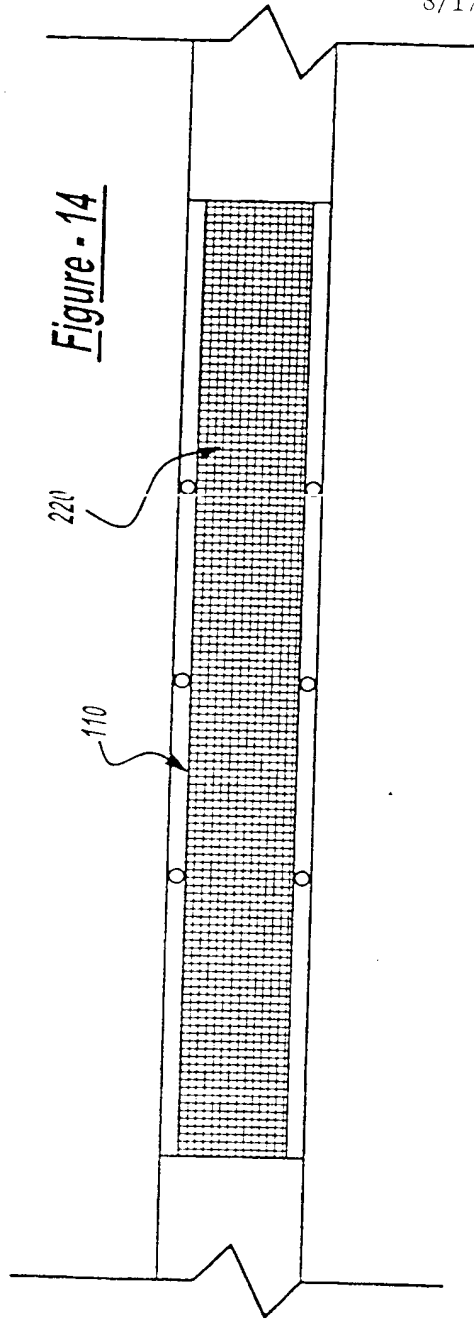
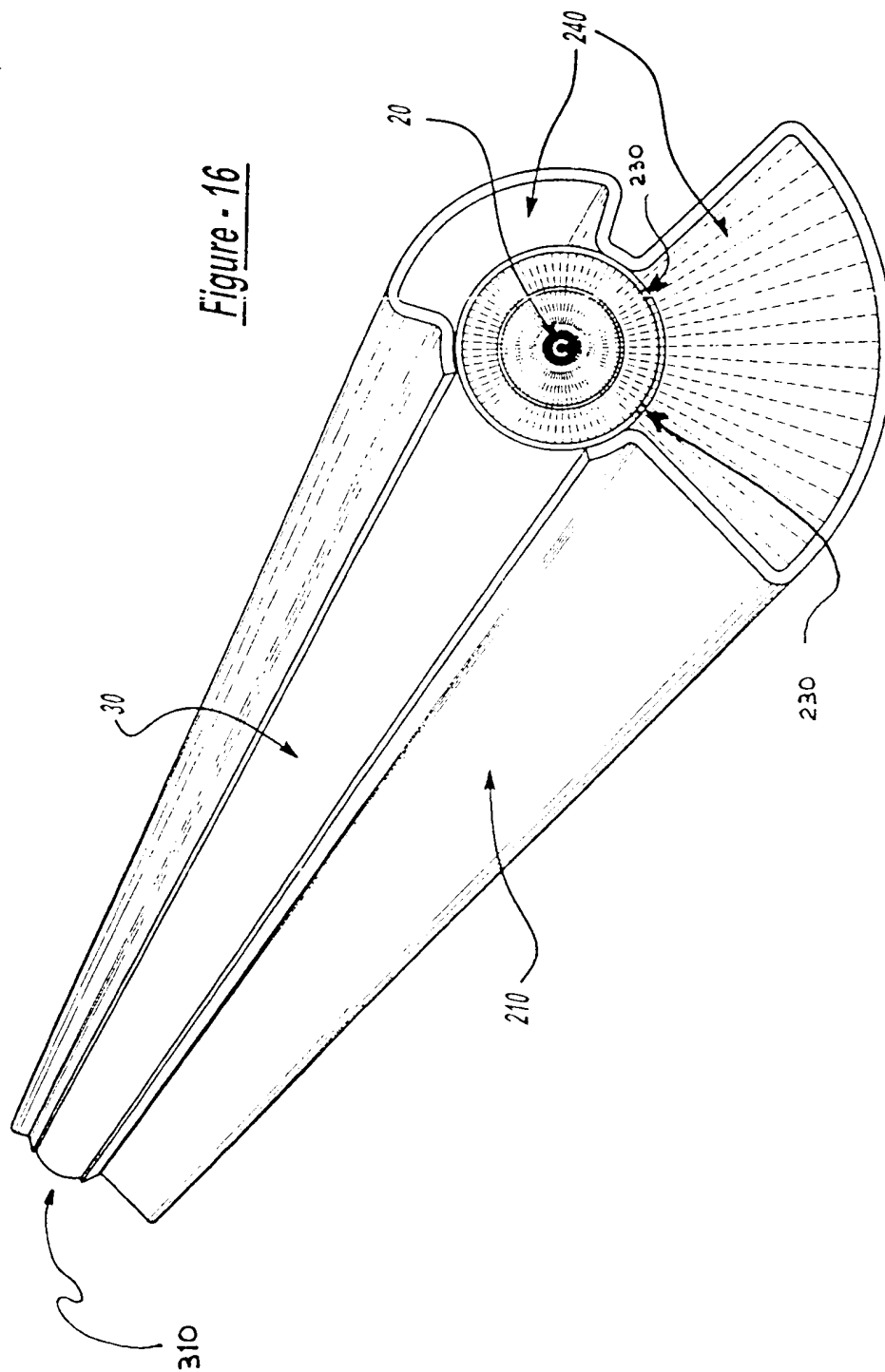


Figure - 15

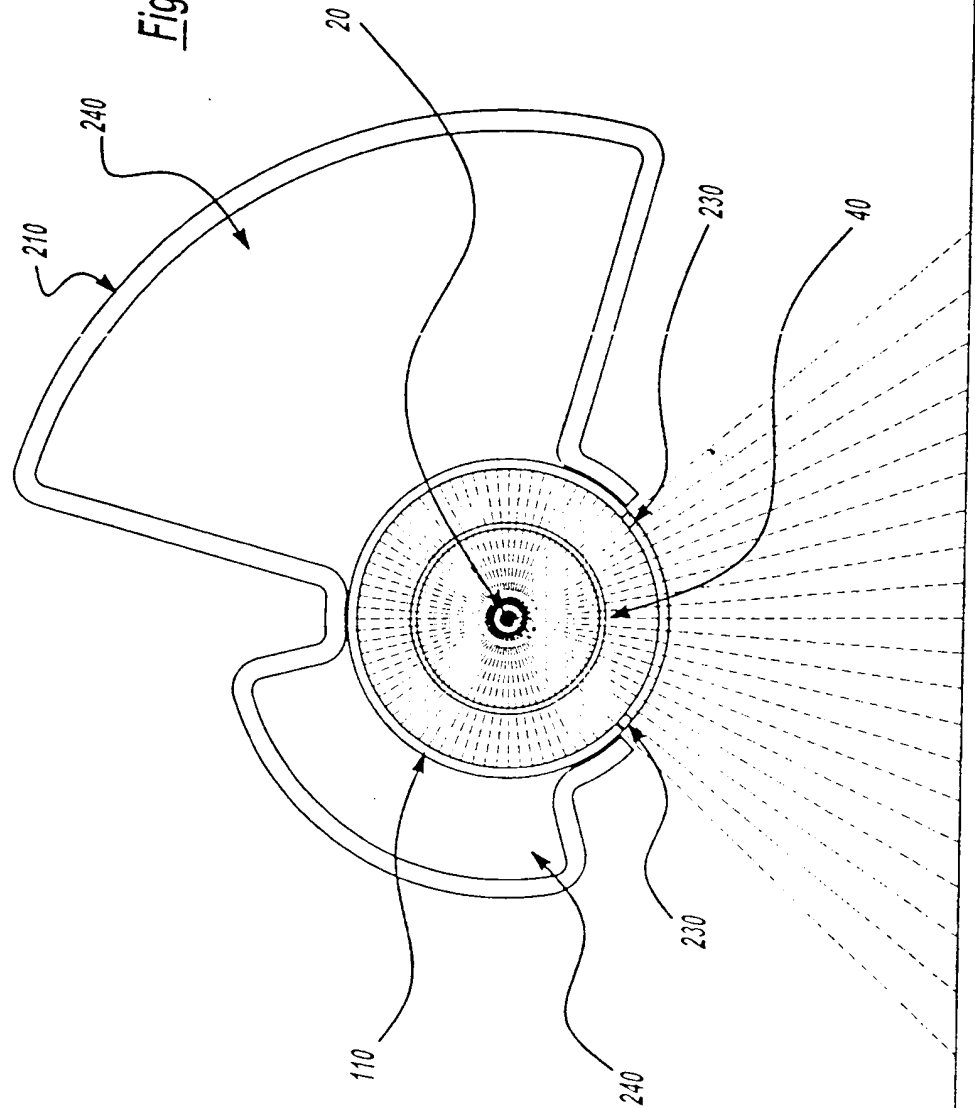
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Figure - 16



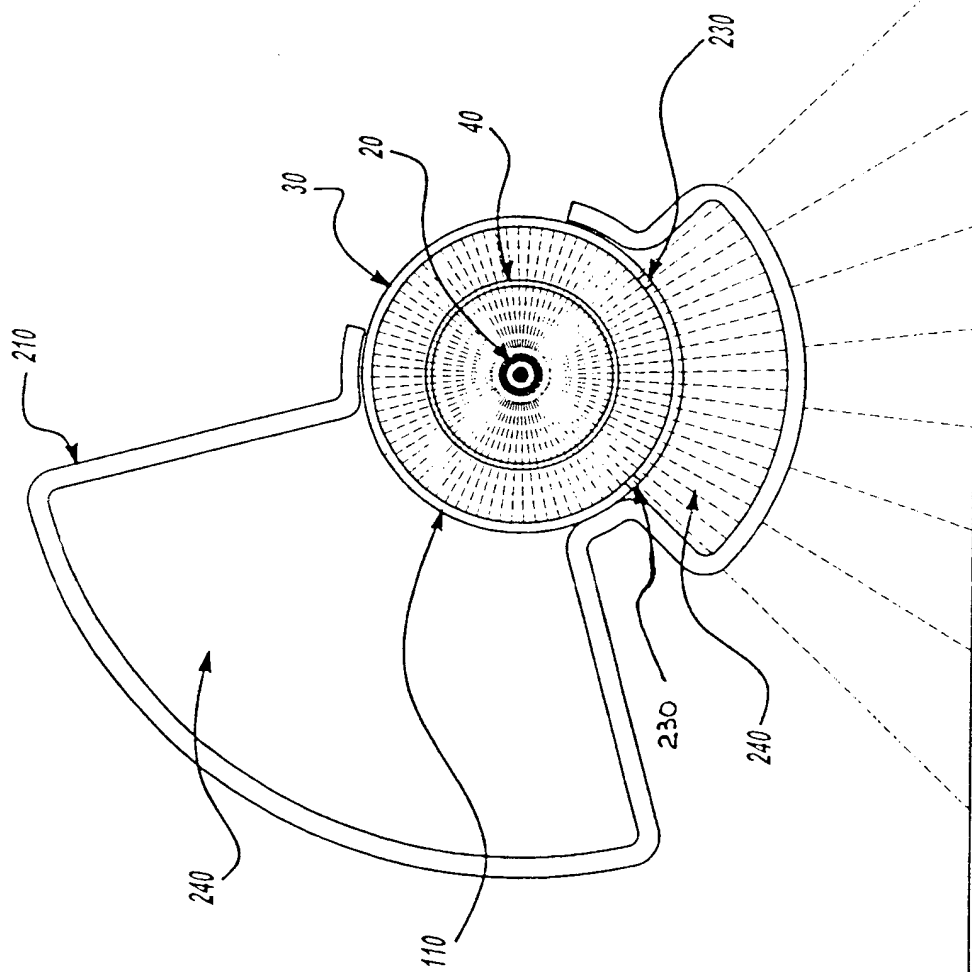
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Figure - 17

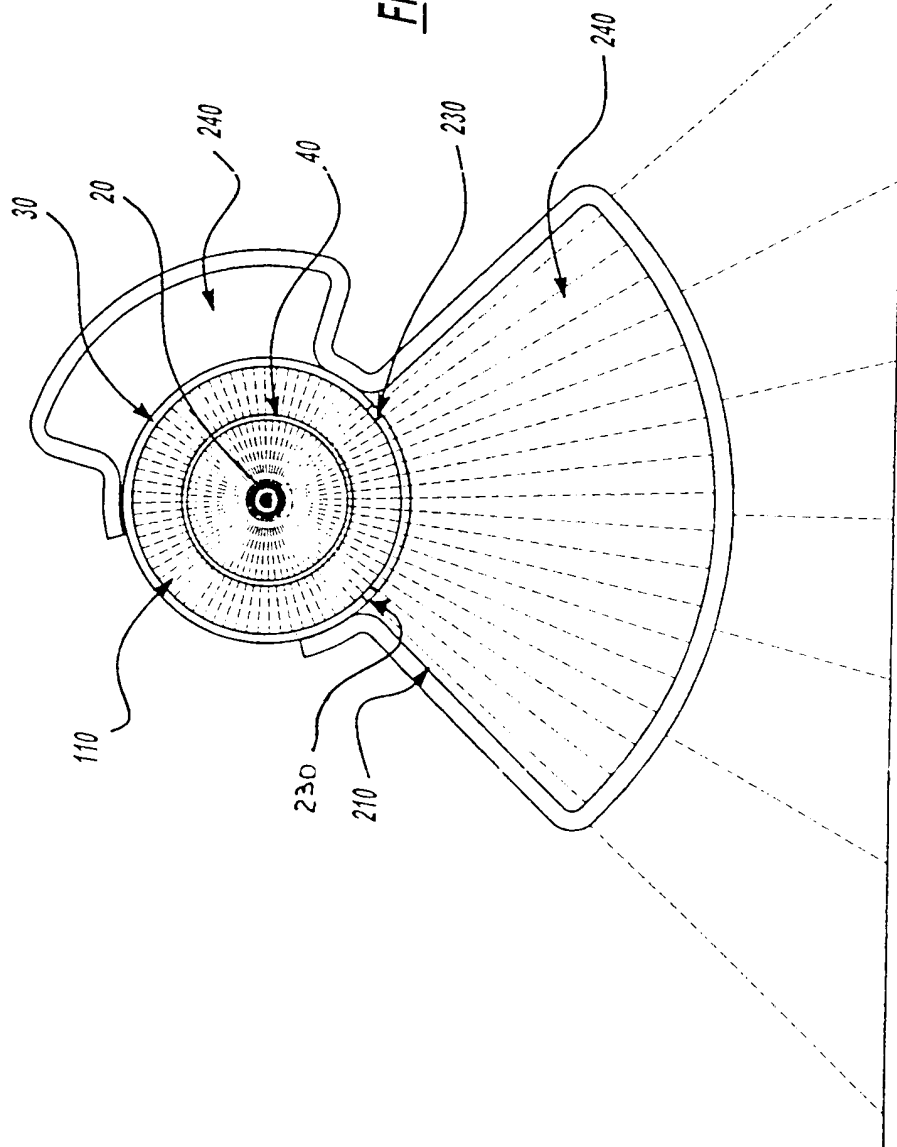


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Figure - 18



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Figure - 19

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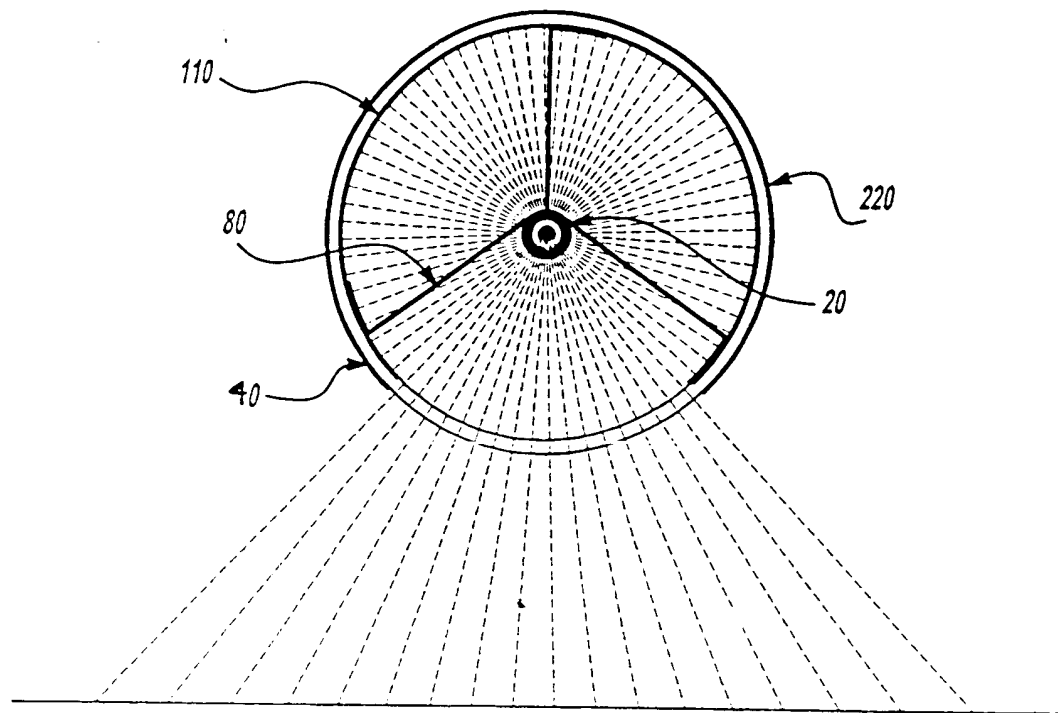
Figure - 20

Figure - 21a

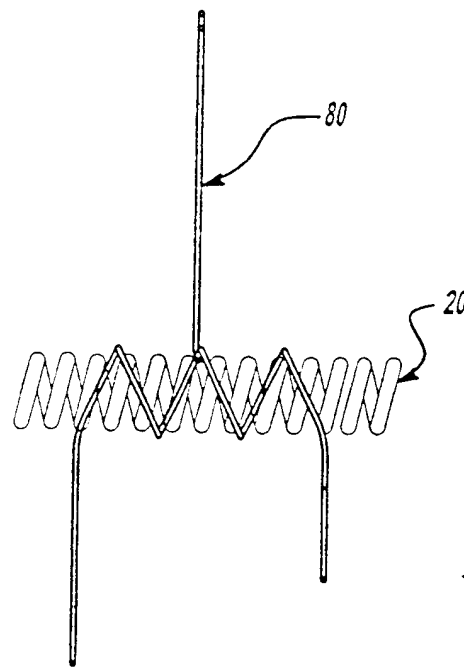
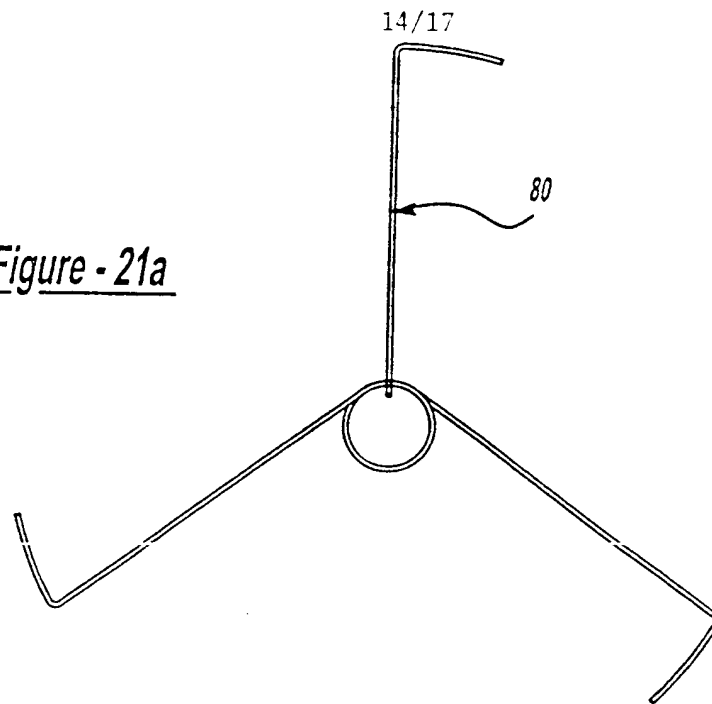


Figure - 21b

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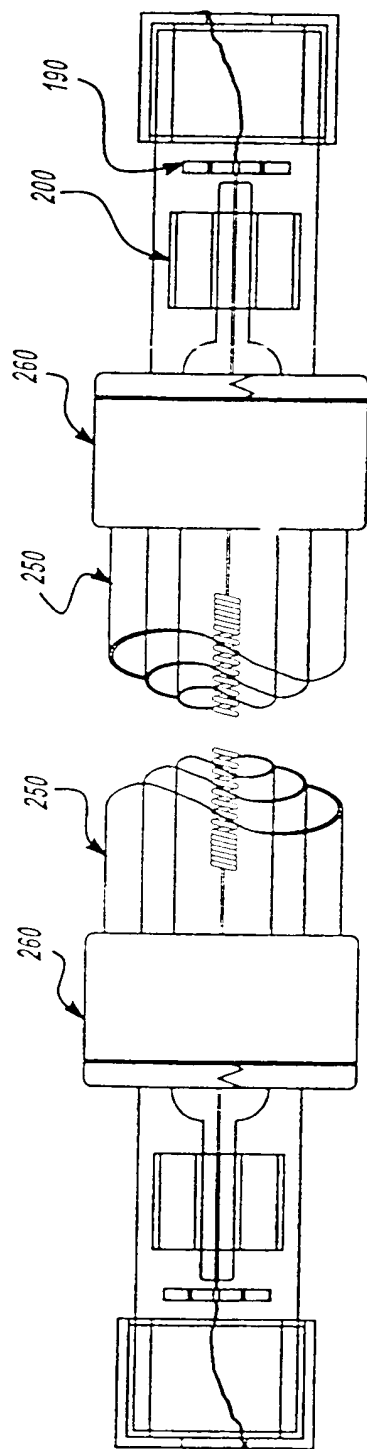


Figure - 22

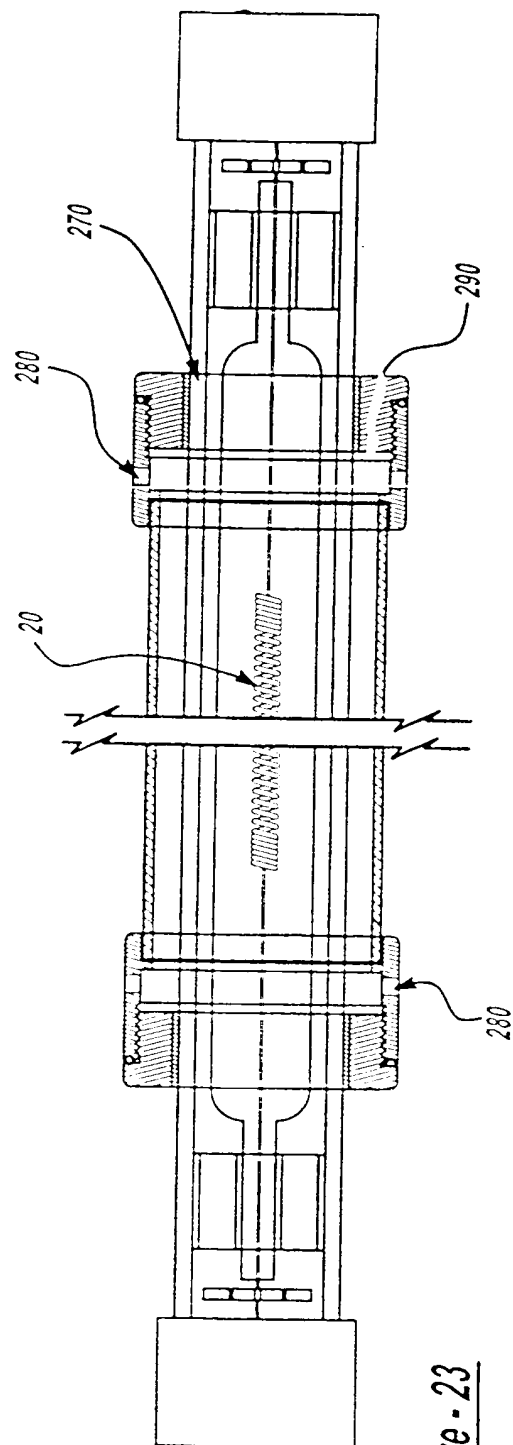


Figure - 23

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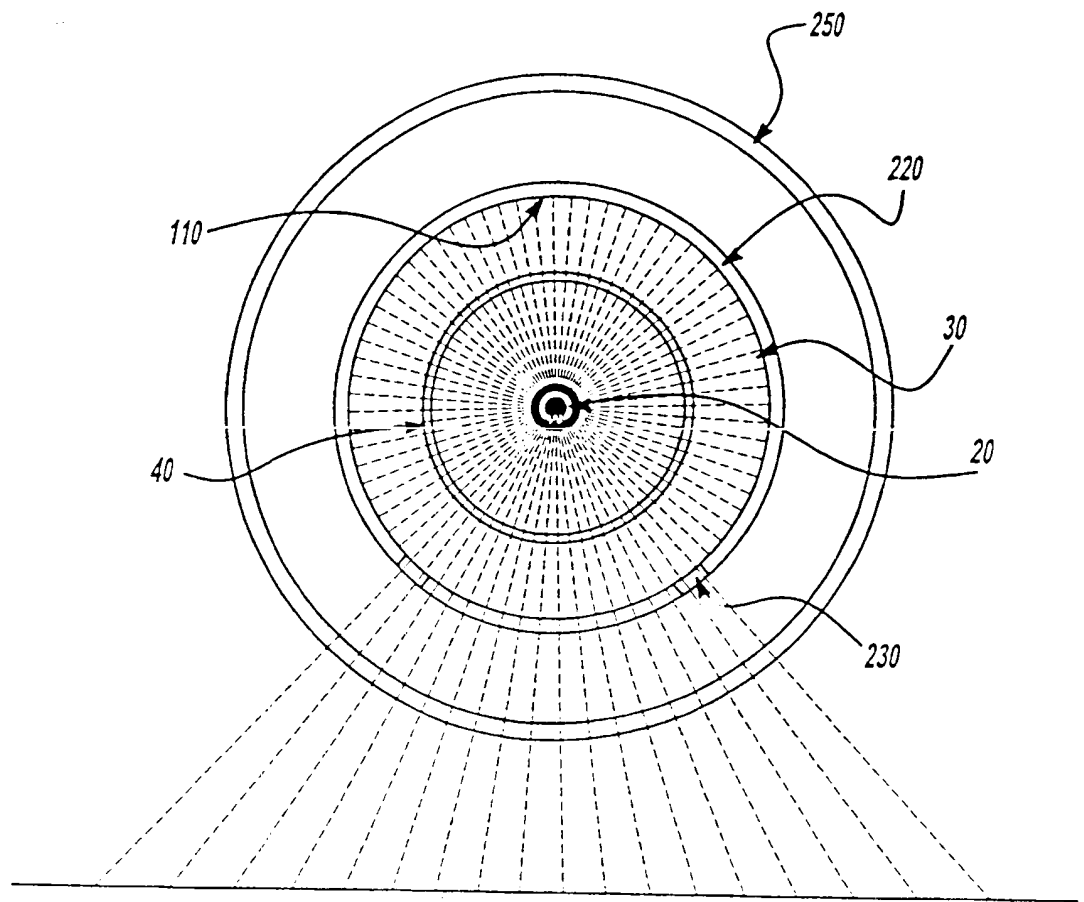
Figure - 24

Figure - 25

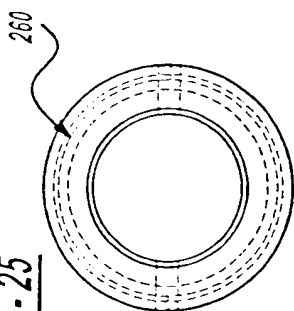
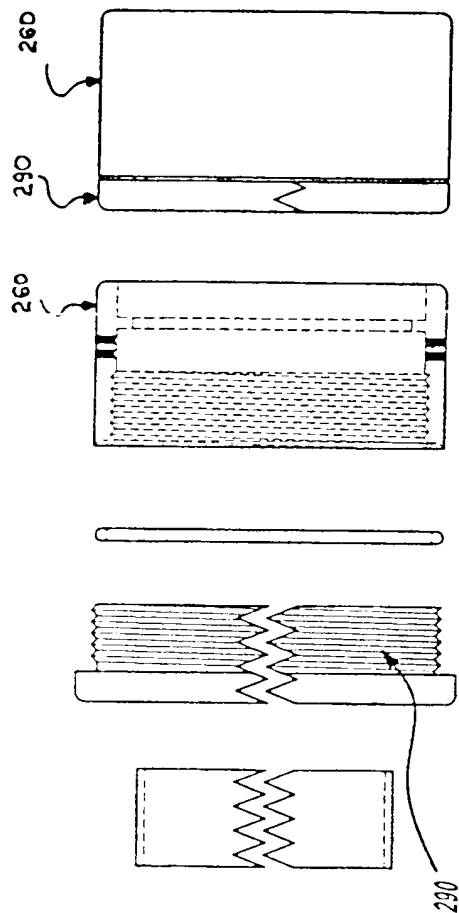


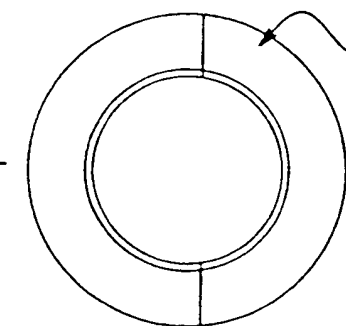
Figure - 26



28

290

300



28

Figure - 27

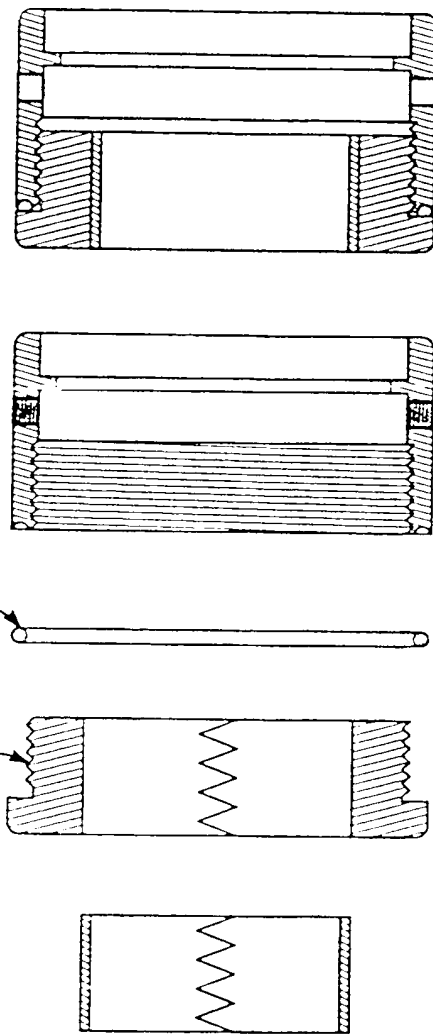


Figure - 28

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(US).

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IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU,
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Published:

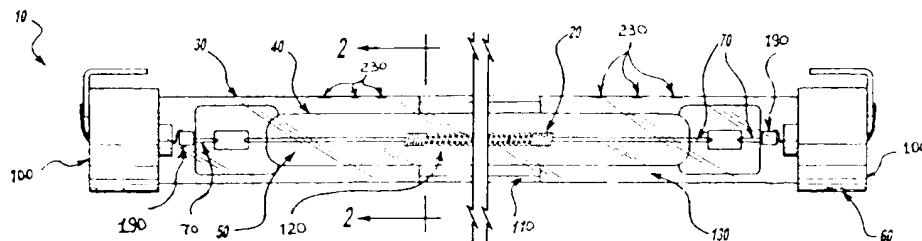
With international search report

(88) Date of publication of the international search report:

11 January 2001

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: EMITTER AND METHOD FOR HEATING AN OBJECT WITH INFRARED ENERGY



(57) Abstract: A method and apparatus for increasing the output of an infrared emitter (10). High temperature concerns affecting the radiant energy transfer efficiency of the infrared emitter (10) are addressed by varying the emitter tube design and varying the locations of both the reflective (110) and high (220) emissivity materials located on the emitter constituent parts. A cooling fluid may be passed through the emitter (10) from both ends to allow higher power density or to cool the emitter (10) during its operation. Selectable wavelength infrared emissions are achieved through the design of the infrared emitter (10).



WO 00/49641 A3

INTERNATIONAL SEARCH REPORT

International Application No.

PCT/US 00/04066

A. CLASSIFICATION OF SUBJECT MATTER

IPC 7 H01K1/34 H01K1/58 H01K1/24 H01K1/28 H01K7/00

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 H01K H01J

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No
X	US 5 382 805 A (FANNON MARK G ET AL) 17 January 1995 (1995-01-17) cited in the application	1-3,5,6, 9,12,22, 23,26, 27,31, 52,60, 62,67
Y	the whole document	7-11,28, 34,35,64
Y	US 4 017 758 A (ALMER FRIEDRICH HERMANN RAYMUN ET AL) 12 April 1977 (1977-04-12)	7-11,28, 34,35
A	abstract; claims 10-14; figures 3-8 column 3, line 53 - line 65 column 4, line 8 - line 52 column 4, line 60 - column 5, line 43 --- -/-	14

☒ Further documents are listed in the continuation of box C☒ Patent family members are listed in annex.

* Special categories of cited documents

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P document published prior to the international filing date but later than the priority date claimed

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Date of the actual completion of the international search

30 May 2000

Date of mailing of the international search report

18.08.00

Name and mailing address of the ISA

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MARTIN VICENTE, A

INTERNATIONAL SEARCH REPORT

International Application No

PC1/US 00/04066

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No
Y	EP 0 828 285 A (MATSUSHITA ELECTRIC IND CO LTD) 11 March 1998 (1998-03-11)	8,11,64
A	abstract; figure 17 column 19, line 56 -column 20, line 2 ---	61
A	US 4 870 316 A (OTANI KATSUYA) 26 September 1989 (1989-09-26) abstract; figure 3 column 5, line 16 - line 25 ---	13
A	EP 0 509 584 A (PHILIPS NV) 21 October 1992 (1992-10-21) figures 3,4 ---	24
A	EP 0 560 420 A (KONINKL PHILIPS ELECTRONICS NV) 15 September 1993 (1993-09-15) abstract; figure 1 column 1, line 23 - line 32 ---	68
A	US 4 611 143 A (SHIMAZU YUJI ET AL) 9 September 1986 (1986-09-09) abstract; figure 4B column 1, line 29 - line 30 column 1, line 67 -column 2, line 10 column 5, line 20 - line 23 -----	68

INTERNATIONAL SEARCH REPORT

International application No.
PCT/US 00/04066

Box I Observations where certain claims were found unsearchable (Continuation of item 1 of first sheet)

This International Search Report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:

1. ☐ Claims Nos. .
because they relate to subject matter not required to be searched by this Authority, namely:
2. ☐ Claims Nos. :
because they relate to parts of the International Application that do not comply with the prescribed requirements to such an extent that no meaningful International Search can be carried out, specifically:
3. ☐ Claims Nos. .
because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).

Box II Observations where unity of invention is lacking (Continuation of item 2 of first sheet)

This International Searching Authority found multiple inventions in this international application, as follows:

see additional sheet(s)

1. ☐ As all required additional search fees were timely paid by the applicant, this International Search Report covers all searchable claims
2. ☐ As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee
3. ☐ As only some of the required additional search fees were timely paid by the applicant, this International Search Report covers only those claims for which fees were paid, specifically claims Nos.
4. ☒ No required additional search fees were timely paid by the applicant. Consequently, this International Search Report is restricted to the invention first mentioned in the claims, it is covered by claims Nos.

1-3, 5-14, 22-28, 31, 34, 35, 60-68

Remark on Protest

- ☐ The additional search fees were accompanied by the applicant's protest.
- ☐ No protest accompanied the payment of additional search fees.

FURTHER INFORMATION CONTINUED FROM PCT/ISA/ 210

1. Claims: 1-3, 5-14, 22-28, 31, 34, 35 and 60-68

Emitters with a reflector, double tubular enclosure and fluid cooling

2. Claims: 37-51 and 70

Emitters with a rotatable outer housing and method for heating an object with an IR emitter having a rotatable outer housing

3. Claims: 52, 53 and 56

IR emitter with a cylindrical enclosure

4. Claims: 4, 29, 32, 33, 36, 54, 69, 71 and 72

Emitters provided with a high emissivity coating and method for heating an object with an IR emitter provided with a high emissivity coating

5. Claims: 15-21

Double wall IR emitters with support device controlling cooling fluid flow

6. Claim : 30

UV emitter

7. Claim : 55

IR emitter with a high temperature filament support

8. Claim : 57

IR emitter with a filament support wrapped in a direction opposite to that of the filament coil

9. Claim : 58 and 59

IR emitter with a coated filament support

INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No

PCT, S 00/04066

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
US 5382805 A	17-01-1995	NONE	
US 4017758 A	12-04-1977	NL 7405071 A	20-10-1975
		AR 203418 A	08-09-1975
		AU 498470 B	15-03-1979
		AU 8006575 A	14-10-1976
		BE 827955 A	15-10-1975
		BR 7502258 A	17-02-1976
		CA 1029078 A	04-04-1978
		DE 2514494 A	30-10-1975
		ES 436575 A	01-01-1977
		FR 2268354 A	14-11-1975
		GB 1463939 A	09-02-1977
		HU 168287 B	28-03-1976
		IT 1037239 B	10-11-1979
		JP 999891 C	30-05-1980
		JP 50138678 A	05-11-1975
		JP 53046397 B	13-12-1978
		SE 394052 B	31-05-1977
		SE 7504207 A	17-10-1975
EP 0828285 A	11-03-1998	JP 10083797 A	31-03-1998
		JP 10261384 A	29-09-1998
		US 6084351 A	04-07-2000
US 4870316 A	26-09-1989	JP 1852764 C	21-06-1994
		JP 5065979 B	20-09-1993
		JP 63259957 A	27-10-1988
		JP 63259956 A	27-10-1988
EP 0509584 A	21-10-1992	DE 69204517 D	12-10-1995
		DE 69204517 T	02-05-1996
		JP 5109386 A	30-04-1993
		US 5252886 A	12-10-1993
EP 0560420 A	15-09-1993	DE 69303949 D	19-09-1996
		DE 69303949 T	13-03-1997
		JP 6005261 A	14-01-1994
US 4611143 A	09-09-1986	JP 59215654 A	05-12-1984
		GB 2144841 A,B	13-03-1985